



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shohei FUJISAWA

Group Art Unit: 2879

Application No.: 10/849,880

. Examiner: 1

er: P. MACCHIAROLO

Filed: May 21, 2004

Docket No.: 119822

For: LIGHT SOURCE UN AND PROJECTOR

LIGHT SOURCE UNIT, METHOD OF MANUFACTURING LIGHT SOURCE UNIT,

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the January 9, 2007 Office Action, and the April 2, personal interview with the Examiner, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.